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| Substitute for form 1449A/PTO | | | | Complete if Known | |
| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary) | | | | Application Number | Based on 10/214,691 |
| | | | | Filing Date | August 9, 2002 |
| | | | | First Named Inventor | Shunpei YAMAZAKI, et al. |
| | | | | Group Art Unit | 2826 |
| | | | | Examiner Name | Fetsum Abraham |
| Sheet | 1 | of | 12 | Attorney Docket Number | 0756-7218 |

10/7/2,062

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| Sheet | 2 | of | 12 | | |

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| | | | | Application Number | Based on 10/214,691 |
| | | | | Filing Date | August 9, 2002 |
| | | | | First Named Inventor | Shunpei YAMAZAKI, et al. |
| | | | | Group Art Unit | 2826 |
| | | | | Examiner Name | Fetsum Abraham |
| | | | | Attorney Docket Number | 0756-7218 |
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| | | | | Examiner Name | Fetsum Abraham |
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| Sheet | 9 | of | 12 | Attorney Docket Number | 0756-7218 |

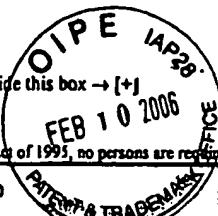
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| Examiner Signature | <i>[Handwritten Signature]</i> | Date Considered | 8/30/05 |
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| | | First Named Inventor | Shunpei YAMAZAKI, et al. |
| | | Group Art Unit | 2826 |
| | | Examiner Name | Fetsum Abraham |
| | | Attorney Docket Number | 0756-7218 |
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| | | | | Examiner Name | Fetsum Abraham |
| Sheet 11 of 12 | Attorney Docket Number | | 0756-7218 | | |

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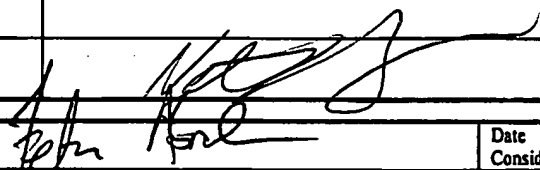
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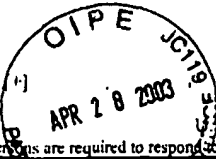
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| NJA | | Office Action dated August 3, 1998 for Application Serial No. 08/784,293. | |
| ME | | Office Action dated February 11, 1999 for Application No. 08/784,293. | |
| ME | | Office Action dated January 17, 2003 for Application No. 08/784,293. | |
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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary) | | Application Number | 10/214,691 |
| | | Filing Date | August 9, 2002 |
| | | First Named Inventor | Shunpei YAMAZAKI et al. |
| | | Group Art Unit | 2826 |
| | | Examiner Name | F. Abraham |
| Sheet 1 of 1 | Attorney Docket Number | 0756-7026 | |

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| WZ | | Wolf, <i>Silicon Processing for the VLSI Era</i> , Volume 2, Chapter 4, page 274 (1990) | |
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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary) | | Application Number | | 10/712,062 | |
| | | Filing Date | | November 14, 2003 | |
| | | First Named Inventor | | Shunpei YAMAZAKI et al. | |
| | | Group Art Unit | | 2826 | |
| | | Examiner Name | | F. Abraham | |
| Sheet | 1 | of | | Attorney Docket Number | 0756-7218 |

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